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PLICATION NO. FILING DATE		ILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/766,896		01/22/2001	Hidemitsu Aoki	WAM-03401 2616	
26339	7590	01/15/2004		EXAMINER	
PATENT C		STEWART	DEO, DUY VU NGUYEN		
EXCHANG	E PLACE	, 53 STATE STREET	ART UNIT	PAPER NUMBER	
BOSTON, I	MA 0210	9		1765	
				DATE MAILED: 01/15/2004	.

Please find below and/or attached an Office communication concerning this application or proceeding.

				-IA					
		Application No.	Applicant(s)						
		09/766,896	AOKI ET AL.						
	Office Action Summary	Examiner	Art Unit	***					
		DuyVu n Deo	1765						
Period fo	The MAILING DATE of this communication Reply	on appears on the cover sheet	with the correspondence addres	S					
THE - Exte after - If the - If NC - Failu - Any	ORTENED STATUTORY PERIOD FOR F MAILING DATE OF THIS COMMUNICAT nsions of time may be available under the provisions of 37 (six (6) MONTHS from the mailing date of this communicate period for reply specified above is less than thirty (30) days to period for reply is specified above, the maximum statutory are to reply within the set or extended period for reply will, by reply received by the Office later than three months after the part of the patent term adjustment. See 37 CFR 1.704(b).	ION. CFR 1.136(a). In no event, however, may ion. s, a reply within the statutory minimum of to period will apply and will expire SIX (6) May statute, cause the application to become	a reply be timely filed hirty (30) days will be considered timely. ONTHS from the mailing date of this commur ABANDONED (35 U.S.C. § 133).	nication.					
1)[\]	Responsive to communication(s) filed on	03 November 2003.							
2a)⊠	This action is FINAL . 2b)	This action is non-final.							
3)□	Since this application is in condition for a closed in accordance with the practice ur	llowance except for formal mander <i>Ex parte Quayle</i> , 1935 C	atters, prosecution as to the mer .D. 11, 453 O.G. 213.	rits is					
Dispositi	ion of Claims								
4) 🖂	Claim(s) 10-14,16-20,22-26,28 and 29 is	are pending in the application	1.						
5)□ 6)⊠ 7)□	4a) Of the above claim(s) is/are withdrawn from consideration. Claim(s) is/are allowed. Claim(s) 10-14,16-20,22-26,28 and 29 is/are rejected. Claim(s) is/are objected to.								
	on Papers	4							
10)[The specification is objected to by the Exa The drawing(s) filed on is/are: a) Applicant may not request that any objection t Replacement drawing sheet(s) including the c The oath or declaration is objected to by the	accepted or b) objected to to the drawing(s) be held in abey correction is required if the drawir	ance. See 37 CFR 1.85(a). ng(s) is objected to. See 37 CFR 1.						
	inder 35 U.S.C. §§ 119 and 120								
a)[* S 13)□ A si 37 a) 14)□ A	Acknowledgment is made of a claim for for All b) Some * c) None of: 1. Certified copies of the priority docu 2. Certified copies of the priority docu 3. Copies of the certified copies of the application from the International B see the attached detailed Office action for cknowledgment is made of a claim for donce a specific reference was included in the CFR 1.78. 1. The translation of the foreign language cknowledgment is made of a claim for dorference was included in the first sentence	ments have been received. ments have been received in e priority documents have bee ureau (PCT Rule 17.2(a)). a list of the certified copies no mestic priority under 35 U.S.C ne first sentence of the specifi te provisional application has mestic priority under 35 U.S.C	Application No In received in this National Stage of received. It is \$119(e) (to a provisional application or in an Application Data been received. It is \$\$120 and/or 121 since a spe	lication) a Sheet. ecific					
Attachment	(s)								
2) 🔲 Notice	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-94- nation Disclosure Statement(s) (PTO-1449) Paper N	8) 5) Notice of	Summary (PTO-413) Paper No(s) Informal Patent Application (PTO-152)						

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DETAILED ACTION

Claim Rejections - 35 USC § 103

- 1. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 2. Claims 10-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Morinaga et al. (US 5,885,362) and Tanabe et al. (US 6,068,000).

Morinaga describes a method for cleaning semiconductor, metal, and glass surfaces using a solution comprising pyrogallol (hydroxy aromatic compound), urea and its derivatives, dimethylenethanolamine (alkanolamine), and water (col. 3, line 37-42; col. 5, line 10-12; col. 7, line 22; col. 8, line 34-40). Even though Morinaga doesn't describes stripping of resist or etching residues from the semiconductor substrate having exposed metal film. However, he teaches using the solution for cleaning/etching of semiconductor, metal, and glass surface (col. 13, line 55-63); therefore, it would have been obvious at the time of the invention for one skill in the art to use the solution in cleaning etching residues from the semiconductor wafer having exposed metal film in order to obtain a clean wafer.

Since Morinaga's solution contains the same two ingredients, hydroxyl aromatic compound and urea/urea derivative as that of the claimed invention, these two components would also supplement each other to form a coating layer that imparts hydrophobicity to the exposed metal film.

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Unlike claimed invention, Morinaga doesn't describe a water-soluble organic solvent Tanabe describes a solution for cleaning or removing degenerate resist on a metal where he teaches using water soluble organic solvent (summery, col. 5, line 45-59). It would have been obvious for one skilled in the art to add a water-soluble organic solvent in light of Tanabe because Tanabe teaches that it would exhibit a high anticorrosive effect for metallic films.

Referring to claim 11, as shown in Morinaga, the amount of each of compound in the solution is determined through test runs in order to see the effective of various concentrations. Therefore, they are result-effective variables and would have been obvious for one skilled in the art to determine the compound concentrations through routine experimentation to achieve optimum concentration in order to clean the wafer with a reasonable expectation of success. See *In re Boesch*, 617 F .2d 272, 205 USPQ 215 (CCPA 1980).

3. Claims 16-20, 22-26, 28, 29 are rejected under 35 U.S.C. 103(a) as being unpatentable over Morinaga, Tanabe, and Zhao et al. (US 6,204,192).

Unlike claimed invention, Morinaga is silent about prior steps forming a semiconductor wafer including steps of forming a metal film (copper), 1st dielectric film, and resist or 2nd dielectric film; etching the 1st dielectric layer using the resist film or 2nd dielectric layer as a mask to expose the metal layer. However, these steps are well known to one skill in the art as shown here by Zhao (fig. 2; col. 4). It would have been obvious to one skill in the art at the time of the invention that Morinaga's method can be used in any semiconductor process, such as a single or dual damascene process taught by Zhao, because Morinaga teaches that his solution can be used to clean/etch semiconductor substrate and prevents a substrate from being deposited with metal impurities (col. 3, line 13-18).

Response to Arguments

4. Applicant's arguments, see pages 15-16 of the remark, filed 11/03/03, with respect to reference of Small have been fully considered and are persuasive. The rejection depending on Small reference has been withdrawn.

Referring to applicant's argument that Morinaga doesn't describe stripping resist or organic layers with exposed metal, as shown in col. 13, line 55-60 and col. 14, line 4, Morinaga teaches of cleaning metal surface so that if is not contaminated with organic materials. Since it is well known to one skill in the art that resist materials are organic materials. Therefore, it would have been obvious for one skill in the art to use the solution to clean the resist, or organic material, from the metal surface.

Referring to applicant's argument that Morinaga teaching of the concentrations of complexing agents are too small to form a coating layer on the surface that imparts hydrophobicity. Morinaga suggests the concentration of each complexing agent added can be up to 2 wt% (col. 12, line 37-43) and page 10, line 14 and page 12, line 5 of the specification show that the concentrations of each of the components, which is the same as Morinaga's complexing agents, have a very good corrosion inhibitability and they are at 1% by mass and 0.1% by mass. Therefore, Morinaga's concentrations of the complexing agents would certainly enough to impart hydrophobicity.

Conclusion

5. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

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A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to DuyVu n Deo whose telephone number is 703-305-0515.

DVD January 6, 2004

> NADINE G. NORTON PRIMARY EXAMINER

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